

Docket Number: 081468-0306523  
Client Reference: P-0371.010-US



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

JAN EVERT VAN DER WERF, et al.

Group Art Unit: 2877

Application No.: 10/693,603

Examiner: Ali Allawi

Filed: October 27, 2003

Confirmation No.: 6464

For: METHOD OF DETECTING MASK DEFECTS, A COMPUTER PROGRAM AND  
REFERENCE SUBSTRATE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. One copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the references have been considered, per MPEP § 609.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 CFR 1.97(e)(1). The references were cited in a foreign counterpart application. A copy of the foreign Official Action is also enclosed for the Examiner's information.

English-language Abstracts of the references are attached hereto.

Respectfully Submitted,

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# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

Form PTO-1449

July 5, 2006

Docket Number

081468-0306523

Application Number

10/693,603

Applicant(s)

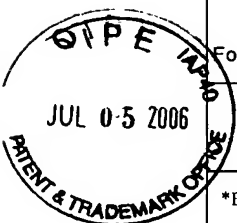
JAN EVERT VAN DER WERF, et al.

Filing Date

October 27, 2003

Group Art Unit

2877



## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						
	L						
	M						
	N						
	O						
	P						

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translations	
							YES	NO
	Q	7-229846	08/1995	Japan				
	R	63-122119	05/1988	Japan				
	S	59-108318	06/1984	Japan				
	T	59-004019	01/1984	Japan				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	U	Japanese Official Action issued for Japanese Patent Application No. 2003-403784, dated April 14, 2006.
	V	
	W	
	X	
	Y	
	Z	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.